

<b>Notice of References Cited</b>	Application/Control No. 09/523,990	Applicant(s)/Patent Under Reexamination LIN ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-JP406196575	07-1994	Hamagishi	257/731
	B	US-JP362169448	07-1987	Hiromasa et al.	257/e23.179
	C	US-5,129,974	07-1992	Aurenus, Carl A. D.	156/64
	D	US-6,476,499	11-2002	Hikita et al.	257/777
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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